



Attorney Docket: 2285/51302
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: YUMIKO KAWANO ET AL.

Serial No. 10/052,306

Filed: January 18, 2002

Continuation of: International Application No.: PCT/JP00/04889

International Filing Date: July 21, 2000

Title: METHOD AND APPARATUS FOR MANUFACTURING
SEMICONDUCTOR DEVICE

TRANSMITTAL LETTER

Box SN

Commissioner for Patents
Washington, D.C. 20231

Sir:

The following are submitted herewith for filing in the above-identified application:

1. Executed Declaration and Power of Attorney
2. Application Data Sheet
3. English Translation
4. Authorization to Charge to Deposit Account No. 05-1323:

\$306 - 17 extra claims over 20
\$84 - 1 extra independent claim
\$130 - surcharge late filing of Declaration
\$130 late filing of translation
\$650 Total to be charged to Deposit Account

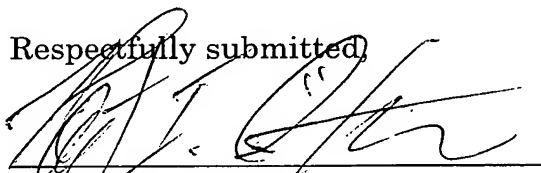
06/26/2002 SSESHE1 00000017 051323 10052306
01 FC:103 306.00 CH
02 FC:102 84.00 CH
03 FC:105 130.00 CH
04 FC:139 130.00 CH

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If there are any questions regarding this submission or the application in general, a telephone call to the undersigned would be appreciated since this should expedite the prosecution of the application for all concerned.

If necessary to effect a timely response, this paper should be considered as a petition for an Extension of Time sufficient to effect a timely response, and please charge any deficiency in fees or credit any overpayments to Deposit Account No. 05-1323 (Docket #2285/51302).

Respectfully submitted,



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June 21, 2002

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